

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **ALEXANDER  
BIETSCH, ET AL.**

Serial No.: **10/787,476**

Filed: **26 FEBRUARY 2004**

For: **SYSTEM, METHOD, AND  
APPARATUS FOR MULTILEVEL UV  
MOLDING LITHOGRAPHY FOR AIR  
BEARING SURFACE PATTERNING**

§ Attorney Docket No.: **HSJ920030074US1**  
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§ Examiner: **EMMANUEL S. LUK**  
§  
§ Confirmation No.: **6992**  
§  
§ Art Unit: **1722**  
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**AMENDMENT A**

MAIL STOP – Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Mr. Luk:

This Amendment is submitted in response to the Office Action dated June 29, 2006, with a shortened statutory period ending on September 29, 2006. Please amend the above-identified application as follows:

CERTIFICATE OF EFS-Web FILING

I hereby certify that this paper is being submitted via the PTO Electronic Filing System to Addressee on the date indicated below and is addressed to Commissioner for Patents – Filing Receipt Corrects.

Date of Submission 8/23/06 By:

